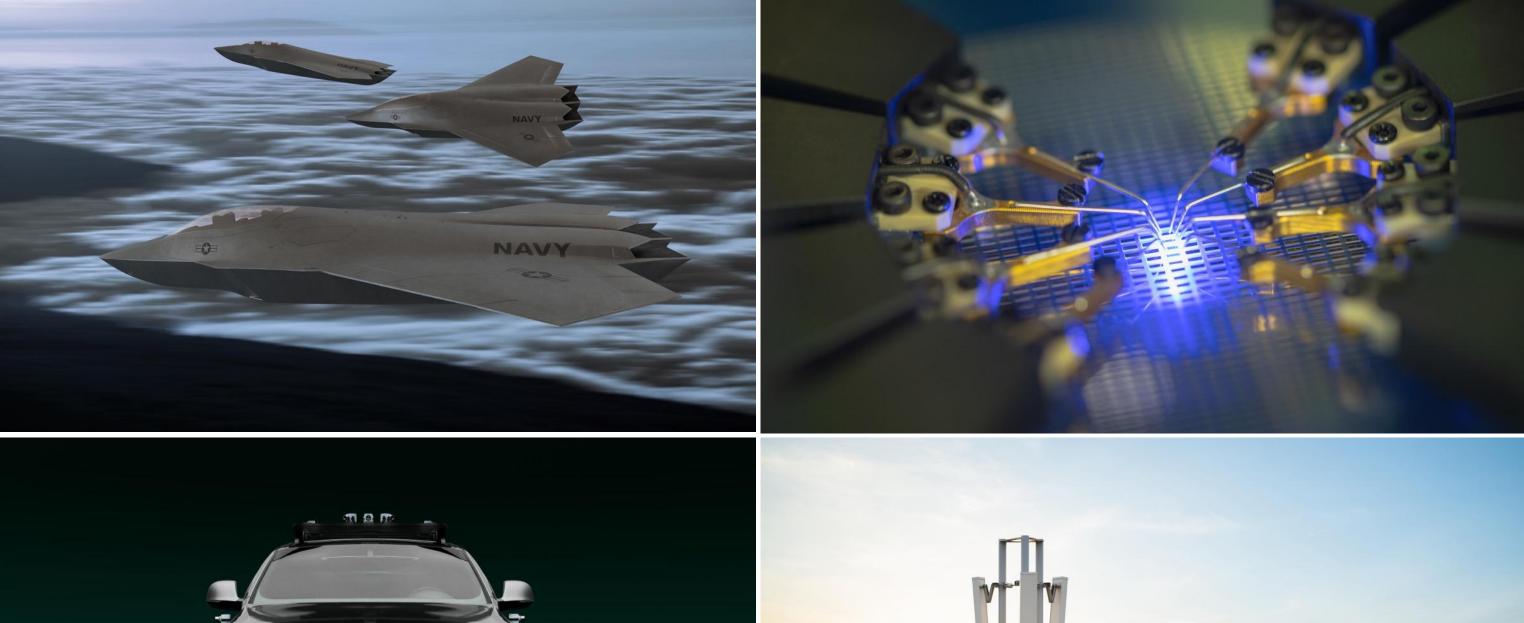
Al over NI Lifecycle Solutions

A Data-centric Approach to Product Lifecycle Performance

March 2024











We've Driven 5 Decades of Disruption

1980s	1990s	2000s	2010s	2020s
Instrument Control				
	Graphical Software			
		Modular Instruments		
			Software-Connected Systems	
				Data and AI



We've Driven 5 Decades of Disruption through Software

INSTRUMENT CONTROL



GRAPHICAL PROGRAMMING



SOFTWARE-DEFINED INSTRUMENTATION





SOFTWARE-CONNECTED SYSTEMS



TestStand & VeriStand



InstrumentStudio & FlexLogger

DATA AND ANALYTICS



DIAdem

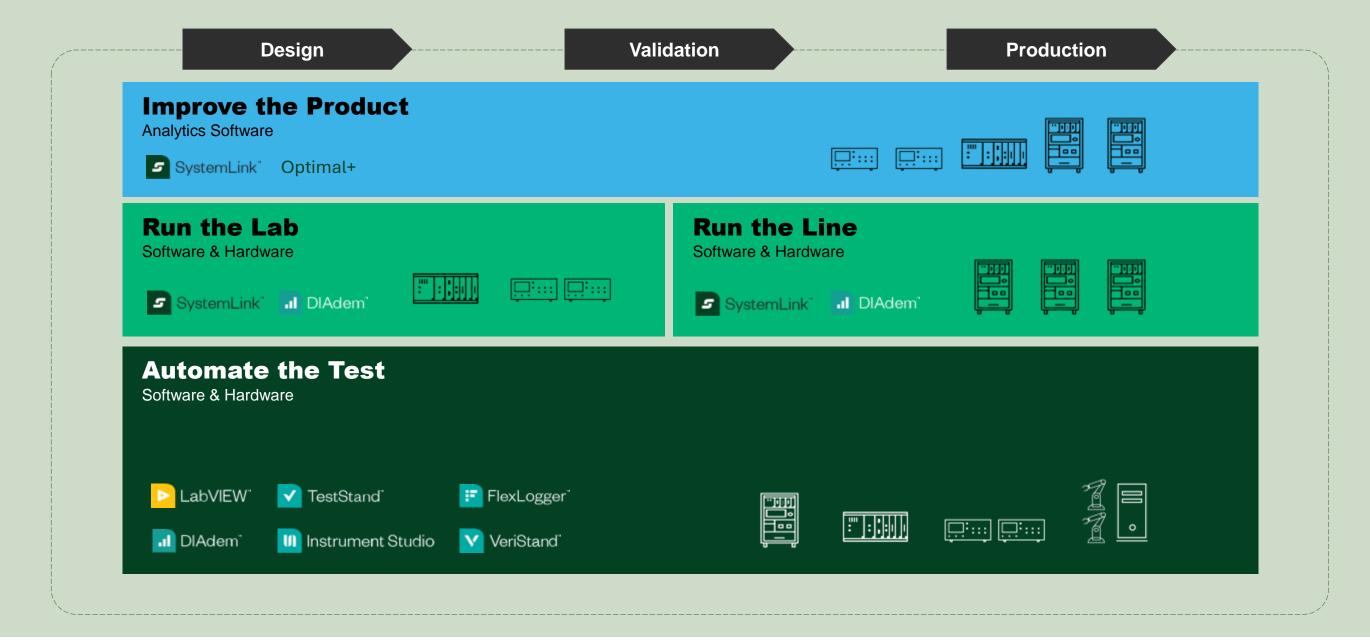


SystemLink





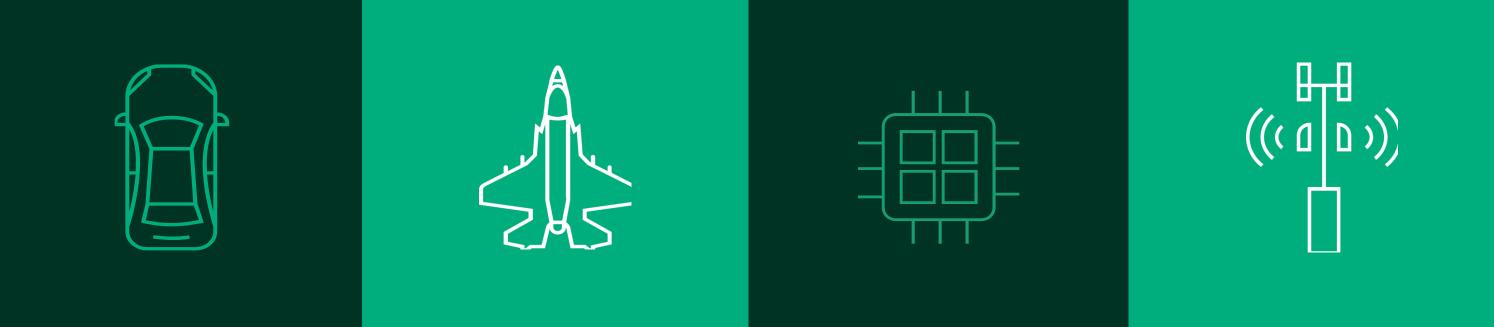
T&M Portfolio | Instrumentation to the Enterprise



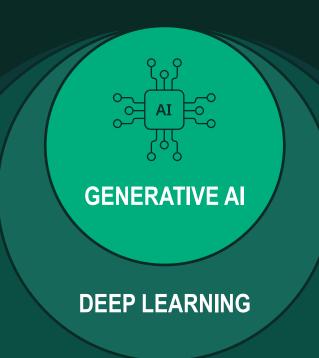


DUT Complexity over Time





THE JOURNEY CONTINUES WITH GENERATIVE AI



MACHINE LEARNING

ARTIFICIAL INTELLIGENCE

2021

GENERATIVE AI

Models which new written, visual, and auditory content given prompts or existing data.

2012

DEEP LEARNING

A machine learning technique in which layers of neural networks are used to process data and make decisions.

1997

MACHINE LEARNING

Subset of AI that enables machines to learn from existing data and improve upon that data to make decisions or predictions

1956

ARTIFICIAL INTELLIGENCE

The field of computer science that seeks to create intelligent machines that can replicate or exceed human intelligence.



INTELLIGENT TEST



INSTRUMENT INTELLIGENCE

- Advanced Measurements
- Real-Time Signal Insights
- Adaptive Test Sequences



USER INTELLIGENCE

- Accelerated Workflow
- Optimized Test Planning
- Rapid Analysis and Reporting

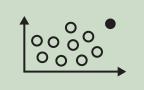


ENTERPRISE INTELLIGENCE

- Improved Asset Utilization
- Increased Yield and Quality
- Enhanced Product Lifecycle Insights



"Traditional" Al Example Use Cases



Outlier detection (Advanced)



Escape prevention (Equipment Health etc.)



Optical defect detection / ROI quality (e.g., welds, soldering etc.)



RMA reduction / prediction



Parametric trend detection



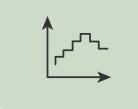
Parametric insights



Scratch detection (wafers)



AI based RCA



Waveform anomaly detection



Battery analytics (capacity, smart pairing, etc.)



Process optimization (e.g., Adaptive manufacturing)



Early failure detection



Next operation reduction



Monitoring and auto RCA (UPH, cycle time, yield, error code distributions etc.)



Equipment utilization/variations



Yield trend detection



Wafer classification



Equipment utilization/variations



Predictive / JIT maintenance



Test (program) comparison

